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Attorney Docket No. 0756-2417

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 10/034,498

Filed: January 3, 2002

For: METHOD OF MAKING A THIN FILM
TRANSISTOR USING LASER
ANNEALING (AS AMENDED)

) Group Art Unit: 2824 ✓

) Examiner: B. Smith

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is being
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) April 5, 2004.

) Adelle M. Stamps

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated December 4, 2003, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Amendments to the Drawings begin on page 19 of this paper and include an attached replacement sheet.

Remarks begin on page 20 of this paper.